

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiji KAI et al.

Serial No. 10/533,030

Confirmation No. 2194

Filed: April 26, 2005

For: Method for Manufacturing  
Micro Lenses including  
Underlayer Film and Lens Film  
Etching Steps (as amended)

Art Unit: 2818

Examiner: Lopez Esquerria, Andres

I hereby certify that this correspondence is  
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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450 on

August 29, 2008

Date of Deposit

Nancy Nolen

Name

Signature

08/29/2008

Date

AMENDMENT

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated April 29, 2008, the time for response to which is extended by one month to August 29, 2008, please amend this application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.